



TO  
AF

**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 1795  
PATENT  
Attorney Docket No. 04329.3304-00**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
Ayako NAKANO et al. ) Group Art Unit: 1795  
Application No.: 10/823,539 ) Examiner: Stephen D. ROSASCO  
Filed: April 14, 2004 ) Confirmation No.: 4440  
For: PATTERN FORMING METHOD AND )  
SYSTEM, AND METHOD OF )  
MANUFACTURING A )  
SEMICONDUCTOR DEVICE )

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REQUEST FOR RECONSIDERATION**

In reply to the final Office Action mailed November 6, 2007, the period for response to which extends through February 6, 2008, Applicants respectfully request reconsideration of the above-identified application in light of the following remarks.